



ELSEVIER

Contents lists available at ScienceDirect

Optics Communications

journal homepage: www.elsevier.com/locate/optcom

Temporally flat top pulse generation from gain switched semiconductor lasers based on a polarization interferometer with variable transfer function

Antonio Consoli*, Ignacio Esquivias

Departamento de Tecnología Fotónica y Bioingeniería—CEMDATIC, Universidad Politécnica de Madrid, Ciudad Universitaria, 28040 Madrid, Spain

ARTICLE INFO

Article history:

Received 29 January 2014

Received in revised form

27 April 2014

Accepted 28 April 2014

Keywords:

Pulse shaping

Polarization interferometer

Flat top pulses

Gain switched semiconductor lasers

Picosecond phenomena

ABSTRACT

We propose the use of a polarization based interferometer with variable transfer function for the generation of temporally flat top pulses from gain switched single mode semiconductor lasers. The main advantage of the presented technique is its flexibility in terms of input pulse characteristics, as pulse duration, spectral bandwidth and operating wavelength. Theoretical predictions and experimental demonstrations are presented and the proposed technique is applied to two different semiconductor laser sources emitting in the 1550 nm region. Flat top pulses are successfully obtained with input seed pulses with duration ranging from 40 ps to 100 ps.

© 2014 Published by Elsevier B.V.

1. Introduction

Optical pulses with duration of tens of picoseconds find application in a wide variety of fields: optical communication channels, imaging, material processing, sensing, optical scanning and ranging [1]. Pulse temporal profile is often relevant, as specific applications require the use of particular pulse shapes. This is the case of flat top pulses which are employed in a large variety of applications, e.g. retiming of high data bit rate optical communication channels in C band [2], efficient pumping of free electron lasers in the deep Ultra Violet wavelength region [3] and amplitude and phase characterization of ultra-short pulses [4].

Common methods for flat top pulse generation are based on spectral filtering of Gaussian, transform limited, ultra-short pulses obtained from mode locked lasers [5]. The general approach is based on pulse spectral filtering by means of a specifically designed photonic device, adapted to the intensity and phase profiles of the seed pulse. The required photonic filter can be implemented with interferometers [6–8], Fiber Bragg Gratings (FBGs) [9–11] or optical differentiators [12,13].

Usually there is a compromise between device design, implementation and tunability. All fiber implementation is usually designed only for a specific input pulse, which has been previously carefully characterized. Free optics elements and movable parts

allows the modification of the photonic filter Transfer Function (TF) and tunability of the device in terms e.g. of obtainable output pulse profiles, operating wavelength and input pulses. The most general case of arbitrary pulse shaping uses a pair of diffraction gratings and a programmable spatial mask: the spectral content is dispersed, properly filtered and then recombined [14]. This solution is widely flexible, but bulky. More recent works have reported fiber implementation and some degree of freedom on its TF given by mechanical action on the fiber. For example, in [7] the Extinction Ratio (ER) of a dual mode fiber interferometer is tuned by twisting the dual mode fiber. In a similar way, in [12] the spectral transmission dip of the proposed differentiator is varied by applying axial straining to the Long Period Fiber Grating (LPPG). However, apart from the ER tuning, the spectral characteristics of the filter, e.g. the Free Spectral Range (FSR) of the interferometer or the central frequency of the differentiator, cannot be varied, thus fixing the operating wavelength and limiting the spectral characteristics of the allowed input pulses.

We have previously proposed a hybrid fiber and free space optics implementation of a polarization based 50:50 Mach-Zehnder (MZ) interferometer with variable delay, for pulse shortening of gain-switched (GS) single mode semiconductor lasers [15]. The spectral TF of the proposed device was properly tuned for suppressing the red frequencies side of the pulse spectrum, thus reducing the falling edge of the pulse temporal profile and its total duration. In [15] pulse shortening has been demonstrated with a Distribute Feedback (DFB) laser and a Vertical Cavity Surface Emitting Laser (VCSEL), both emitting in the 1550 nm region.

* Corresponding author. Tel.: +34913367366; fax: +34913367319.

E-mail addresses: antonio.consoli@upm.es, snatcos@gmail.com (A. Consoli).

The pulse at the interferometer input had durations in the range of tens of picoseconds, typical of GS lasers, similar to the pulses presented in this work.

In this manuscript, we extend our previous work with the implementation of a polarization based interferometer, similar to the one presented in [15], in which the input coupling, output coupling and temporal delay between the two arms can be easily tuned. We demonstrate flat top pulse generation from a DFB laser and a VCSEL operating at different wavelengths in the 1550 nm region. Different pulses were generated from the GS devices by varying the gain switching parameters and flat top pulses are obtained in all cases by properly tuning the interferometer parameters.

This work is organized as follows: the principle of operation of the proposed technique and the performed numerical simulations are presented in Section 2; Section 3 describes the experimental results and in Section 4, the main conclusions are presented.

2. Principle of operation and numerical simulations

The principle of operation of the proposed technique is based on the use of a chirped pulse at the interferometer input. Pulse shaping is obtained with spectral amplitude filtering, based on the time-frequency correspondence of the input chirped pulse. The central part of the pulse spectrum, which corresponds to the pulse peak in time, is properly attenuated in order to flatten the pulse peak in time and obtain a flat top temporal profile at the interferometer output. This corresponds to use a notch-like filter, with minimum of transmission placed at the pulse spectrum central frequency and with suitable notch depth.

The proposed notch filter is an interferometer with variable TF, in which the ER can be changed by varying the coupling ratios between the two interferometer arms (k_1 and k_2) and its FSR can be tuned by varying the temporal delay τ between the interferometer arms. Experimentally, this solution is implemented with a polarization based interferometer, described in detail in Section 3.

Pulses at the interferometer input are generated by gain switching a semiconductor laser, which gives almost linearly chirped pulses. The entire system has been numerically simulated. Pulses at the interferometer input have been obtained in simulations using the density rate equations for photons, carriers and phase [15] with typical parameters for a 1550 nm DFB laser [16]. Pulses are generated by gain switching the laser with the current $I(t)$, given by the sum of a Direct Current (DC) term, I_{BIAS} , and a sinusoidal current with amplitude I_{AMP} and frequency f_{GS} , i.e. $I(t) = I_{BIAS} + I_{AMP} \cdot \sin(2\pi f_{GS}t)$.

The output pulse power, $P(t)$, and phase, $\phi(t)$, are obtained from the density rate equations and the pulse complex envelope is calculated as $E(t) = \sqrt{P(t)}\exp[j\phi(t)]$, where t is the time variable

and j is the imaginary unit. The instantaneous frequency $\nu(t)$ is calculated from the time derivative of the phase, i.e. $\nu(t) = (2\pi)^{-1} d(\phi(t))/dt$.

The complex pulse spectrum is then obtained as $\tilde{E}(f) = FT[E(t)]$, where FT is the Fourier Transform operator and f the frequency domain variable.

Fig. 1 show the simulation results for $I_{BIAS} = I_{TH}$, $I_{AMP} = 4I_{TH}$ and $f_{GS} = 1$ GHz, where I_{TH} is the threshold current of the simulated laser. The gain switching parameters (I_{BIAS} , I_{AMP} and f_{GS}) have been chosen in order to have similar results in comparison with experiments. The simulated pulses have Full Width Half Maximum (FWHM) duration of about 65 ps and a spectral bandwidth at $1/e^2$ of 33.5 GHz.

Typical features of pulses from GS semiconductor lasers can be observed in Fig. 1(a): asymmetric temporal intensity profile and carrier induced negative variation of instantaneous frequency. In Fig. 1(b), the expected broadened spectrum, with intensity modulation due to the relaxation oscillations at this bias point, and the corresponding group delay are shown.

The interferometer TF, $H(f)$, of a MZ interferometer has been numerically implemented as $H(f) = j\sqrt{k_1(1-k_2)} + j\sqrt{k_2(1-k_1)} \exp(j2\pi f\tau)$ [17] where τ is the temporal delay between the two interferometer arms and k_1 and k_2 are the coupling ratios at the input and output coupler, respectively. For each optical coupler, the coupling ratio k is defined as the fraction of output power of the output port in direct pass to the total output power. The pulse spectrum at the interferometer output is calculated as $\tilde{E}_{OUT}(f) = \tilde{E}(f)H(f)$ and its temporal complex envelope, $E_{OUT}(t)$, is obtained after Inverse Fourier Transforming (IFT), as $E_{OUT}(t) = IFT[\tilde{E}_{OUT}(f)]$.

In order to compare the simulated pulses at the interferometer output with an ideal rectangular pulse, we introduce a simple Flat Top Form Factor (FTFF), defined as:

$$FTFF = \frac{\int_{t_1}^{t_2} [y(t) - y_{TH}] dt}{\int_{t_1}^{t_2} [rect(t) - y_{TH}] dt} \quad (1)$$

where $y(t)$ is the pulse under study, $rect(t)$ is an ideal rectangular pulse, with constant width given by $W = t_2 - t_1$, and t_1 and t_2 are the time instants in which $y(t)$ crosses the threshold value y_{TH} . The FTFF definition is schematically depicted in Fig. 2.

The FTFF gives an estimation of how much the waveform under study resembles an ideal rectangular pulse with a given width, set by the threshold value y_{TH} . If $y(t)$ is an ideal rectangular pulse, $FTFF = 1$, in any other case, $FTFF < 1$ and its value depends on the shape of $y(t)$ and y_{TH} . We set y_{TH} equal to $1/e^2$ of the pulse maximum, which gives $FTFF = 0.48$, for the simulated pulse with asymmetric intensity profile shown in Fig. 1.

We performed simulations with the aim of maximizing the FTFF of the output pulse, using at the interferometer input the

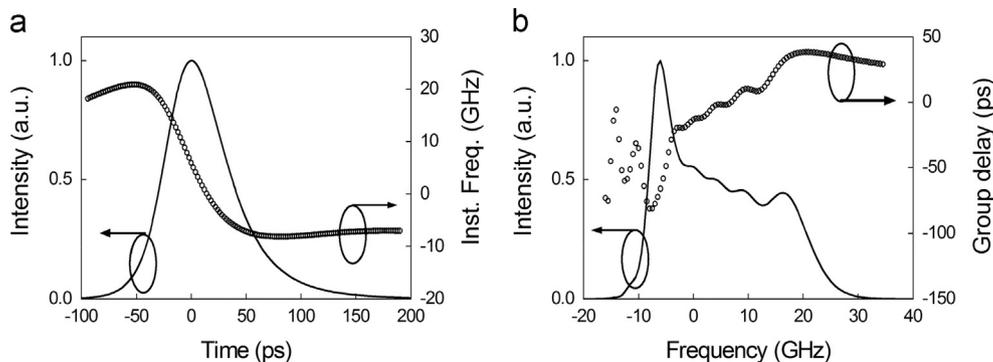


Fig. 1. Simulation results for the simulated GS DFB laser with $I_{BIAS} = I_{TH}$, $I_{AMP} = 4I_{TH}$ and $f_{GS} = 1$ GHz: (a) Temporal intensity (solid line, left axis) and instantaneous frequency (open circles, right axis) and (b) spectral intensity (solid line, left axis) and group delay (open circles, right axis).

pulse shown in Fig. 1 and varying the interferometer FSR and ER, considering that $FSR=1/\tau$ and $ER=10\log_{10}(P_{MAX}/P_{MIN})$, where P_{MAX} and P_{MIN} are the maximum and minimum transmission of the TF of the interferometer, respectively.

In a first set of simulations the ER was changed and the FSR was fixed at a value equal to the pulse bandwidth at $1/e^2$, 33.5 GHz. A minimum of the interferometer TF was placed at the pulse spectrum center ($f=0$ GHz in Fig. 1). The ER was varied by changing k_2 , with $k_1=0.5$.

The calculated FTFF is shown in Fig. 3, for ER between 0 dB ($k_2=0$, plain TF) and 9.5 dB ($k_2=0.2$), while Fig. 4(a) shows the intensity and instantaneous frequency for three particular values of ERs (0 dB, 3 dB and 9.5 dB).

For ER=0 dB, a value of FTFF=0.48 is obtained corresponding to the FTFF of the input pulse. As the ER is increased, the pulse peak is progressively flattened and the FTFF increases up to a maximum of 0.56, obtained for ER=3 dB ($k_2=0.025$). This case is illustrated in Fig. 4(a). For greater values of the ER, the FTFF decreases, as the spectral dip in the interferometer TF is more pronounced and double peaked pulses are generated at the interferometer output, as shown in Fig. 4(a), for ER=9.5 dB.

Fig. 4(a) also shows that the instantaneous frequency variation of the original pulse (about 30 GHz) is maintained. For small values of the ER, the spectral phase profile of $H(f)$ presents a smooth phase transition, as shown in Fig. 4(b), where a maximum phase variation of 0.3 rads is observed. For higher values of ER, the phase jump is stepper, until reaching a π transition for the maximum ER ($k_2=0.5$), as confirmed by simulations. In Fig. 4 (c) the intensity and group delay of the output pulse spectrum are plotted. It is worth noting that the group delay of the output pulse is almost the same than the input pulse (Fig. 1), showing that the

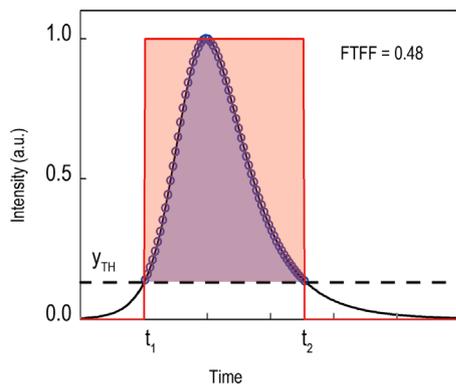


Fig. 2. Visual representation of the FTFF definition applied to the simulated input pulse, shown in Fig. 1. An ideal rectangular pulse is constructed from y_{TH} and the FTFF is given by the ratio between the areas under the rectangular pulse (red line) and $y(t)$ (open circles). (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

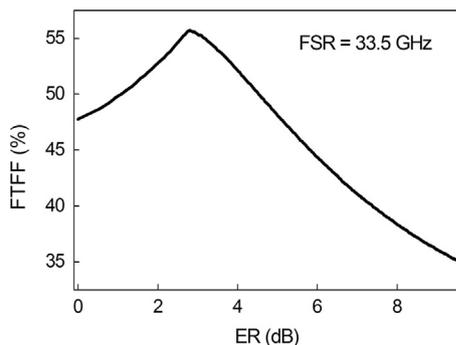


Fig. 3. The FTFF calculated for FSR=33.5 GHz as a function of the ER.

temporal distribution of the pulse spectral content is maintained after passing through the interferometer.

A second set of simulations was performed with fixed ER=3 dB and varying the FSR. A minimum of the interferometer TF was always considered at the center of the input pulse spectrum. The calculated FTFF as a function of the FSR and the pulse intensity and instantaneous frequency for selected examples are shown in Figs. 5 and 6, respectively.

Maximum values (~ 0.57) of the FTFF parameter are found for a FSR between 25 GHz and 30 GHz. The intensity and instantaneous frequency obtained for FSR=28 GHz are shown in Fig. 6: a flat top pulse with slightly more pronounced oscillations of the peak plateau, with respect to the case of FSR=33.5 GHz, is obtained and the same total amount of instantaneous frequency variation of the input pulse is maintained.

For smaller values of the FSR, more than one spectral period of $H(f)$ falls into the pulse spectrum, thus exiting the regime of operation, where a notch-like TF has been assumed as the required filter for flat top pulse generation. As an example, the case FSR=10 GHz is shown in Fig. 6, where a satellite pulse preceding the main pulse peak and an irregular and discontinuous profile of the instantaneous frequency can be observed. For FSR \geq 30 GHz, the spectral dip in $H(f)$ exceeds the pulse spectral bandwidth, broadening the pulse duration and smoothing the pulse peak plateau, as shown in Fig. 6, for the case FSR=60 GHz.

The result obtained in Fig. 5 is understood as a simple filter design rule, following which the optimal value for FSR is slightly less than the full pulse spectrum at $1/e^2$.

Previous results define two simple conditions for filter design: (i) a minimum of transmission of $|H(f)|^2$ must be placed at the center spectrum and the FSR has to be in the order or slightly smaller than the full spectrum width (measured at $1/e^2$ of the maximum), (ii) small values of the ER (3 dB for the input pulse considered in the simulations) are the optimal choice and can be obtained with $k_1=0.5$ and varying k_2 until a flat top pulse profile is obtained.

Concerning the spectral phase of the proposed filter, an ideal constant phase profile has been assumed describing the proposed principle of operation, which is not the case for a real interferometer TF. However, simulations have shown that, for the cases of interests, the instantaneous frequency of the output and input pulse are similar. This is due to the fact that for the generation of a flat top pulse profile a small ER is required, which corresponds to smooth spectral phase transitions of $H(f)$, as predicted by theory and pointed out in detail in Ref. [12]. In fact, a spectral phase π jump at a minimum transmission frequency is expected only in case of a 50:50 interferometer, i.e. with maximum ER. For smaller values of ER the spectral phase transition is smoother and its effect is negligible, as previously shown with presented simulation results.

The proposed technique implies pulse energy loss, as part of the input pulse spectrum is suppressed for shaping the pulse intensity profile. On the other hand, the small ER required for flat top pulse generation causes a total energy loss of 53%, as obtained from simulation, by comparing the spectral energy of the output and input pulses, in the cases of flat top pulse generation, i.e. FSR=28 GHz and 33.5 GHz and ER=3 dB (see Figs. 4 and 6).

3. Experiments

The experimental set-up is shown in Fig. 7. The output of a GS Laser Diode (GS LD) is split in two paths via a 50:50 fiber coupler: one path is directly connected to a fast (20 GHz bandwidth) photodiode (PD) and to the channel 1 (CH1) of a digital sampling

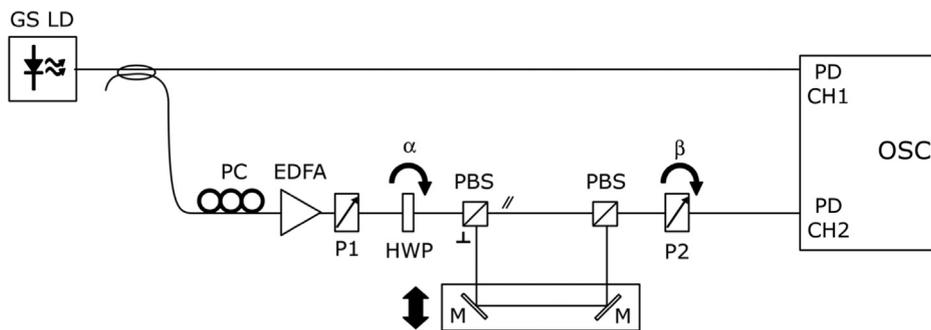


Fig. 7. Experimental set-up. Details are given in the text.

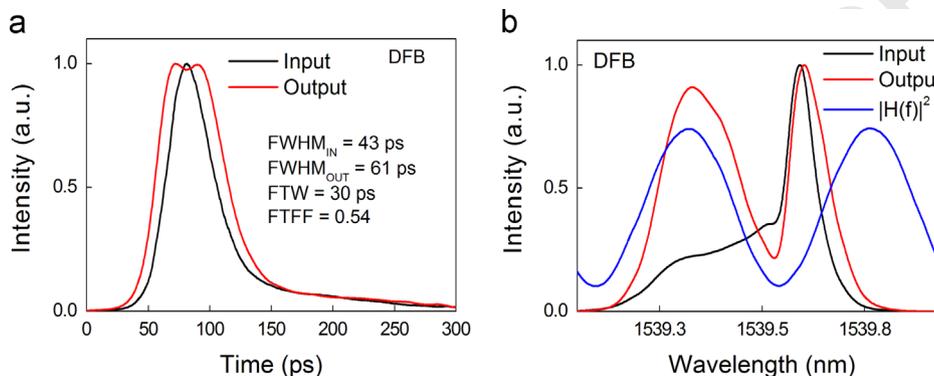


Fig. 8. Experimental results with the DFB laser, for $f_{RF}=1$ GHz, $P_{RF}=16$ dBm and $I_{BIAS}=I_{TH}$: (a) temporal intensity profiles of the input (black line) and output (red line) pulses, (b) input pulse (black line), output pulse (red line) spectra and interferometer TF (blue line). (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

minimum of transmission of $|H(f)|^2$ coincides with the central wavelength of the input spectrum at $(\lambda_1 + \lambda_2)/2$.

Experimentally, the minimum step of the motorized translation stage, $\Delta\tau$, limits the obtainable resolution in setting the FSR and so the central frequency of the filter, $\nu_0 = m \cdot \text{FSR}$, being m an integer. The resolution in the FSR, $\Delta\nu$, can be estimated as $\Delta\nu \approx \Delta\tau/\tau^2$, yielding values of $\Delta\nu$ between 16 MHz and 4 MHz, for delays between 10 ps and 20 ps (as in this work), respectively. The resolution in the central frequency $\Delta\nu_0$, at constant m , is then $m \cdot \Delta\nu$, ranging between 32 GHz and 16 GHz, for the delays considered. This resolution does not allow fine tuning of ν_0 for the pulse bandwidth considered in experiments (~ 50 GHz at $1/e^2$).

However, as the value of m is high (2000–4000), it is always possible to find an interferometer minimum of transmission close to the central frequency of the input pulse spectrum by changing the delay time and selecting a different value of the integer m . For an arbitrary change of the delay τ , the distance between the laser central frequency and the interferometer minimum of transmission ranges between zero and $\text{FSR}/2$. It is then possible to tune ν_0 after a few trials, in which the translation stage of the DPDL is moved a few steps forward and backward with respect to the desired delay, until the desired ν_0 is obtained and a flat top profile is observed at the oscilloscope. In our experiments, we were able to select the desired ν_0 with a resolution better than 3 GHz after a small number (< 10) of attempts.

Pulses obtained at the interferometer output were measured with a 45 GHz photodiode (PD New Focus 1014) at the channel 2 (CH2) of the sampling oscilloscope.

Two commercially available semiconductor lasers emitting in the 1550 nm region were used for pulse generation: a DFB laser (Uni-phase) and a VCSEL (Raycan). Lasers were driven in gain switching conditions by means of a Radio Frequency (RF) sinusoidal signal at frequency f_{RF} , with nominal output power P_{RF} and a DC current

term I_{BIAS} . The laser temperature was controlled with a Thermo Electric Cooler (TEC) and all measurements are performed at 25 °C.

Fig. 8 shows an example of the generation of a flat top pulse from the GS DFB laser. The input pulse had a FWHM duration of 43 ps, spectral width at $1/e^2$ of 0.45 nm (56.2 GHz), centered at 1539.46 nm and a FTFF=0.43. The interferometer parameters were finely tuned to optimize the flat top profile by observing the temporal shape of the output pulse. Best results were obtained with $\tau=17.94$ ps (FSR=55.7 GHz) and ER=8.7 dB.

Very stable behavior (over 30 min) has been observed in the interferometer TF and the output pulse shape, provided that the two optical paths of the interferometer were thermally insulated from ambient temperature fluctuations. This has been obtained by covering the DPDL with a 1.5 cm thick layer of polyurethane.

The filtered pulses have been characterized by measuring their FWHM, FTFF and a Flat Top Width (FTW), defined at 95% of the pulse maximum and only pulses with less than 5% dip in the flat peak region have been considered. Results are presented in Fig. 8 (a), where a flat top pulse with FWHM of 61 ps and a FTW of 30 ps is shown. The FTFF obtained in this case is 0.54. Fig. 8(b) shows the input and output pulse spectra and the measured interferometer TF. A minimum of transmission was placed at about 1539.5 nm and a double peaked profile of the output pulse spectrum was obtained.

Similar experiments were performed with the GS VCSEL, see Fig. 9(a) and (b). The obtained pulses had a FWHM of 69 ps and spectral width at $1/e^2$ of 0.53 nm (66.2 GHz). The calculated FTFF is 0.5 in this case. The central wavelength of the VCSEL was at about 10 nm away (1550.6 nm) from the DFB emission, demonstrating the tunability of the proposed technique in terms of operating wavelengths. In this case, the delay τ was set to 12.684 ps and the ER of the interferometer was 6.6 dB. The resulting output pulse had a FWHM of 104 ps, a FTW of 52 ps and FTFF=0.59. The

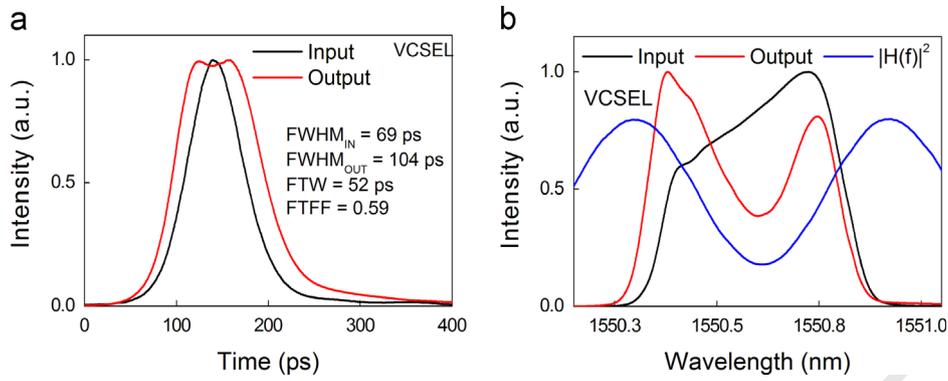


Fig. 9. Experimental results with the VCSEL, with $f_{RF}=1$ GHz, $P_{RF}=14$ dBm and $I_{BIAS}=1.1 I_{TH}$: (a) temporal intensity profiles of the input (black line) and output pulse (red line), (b) input pulse (black line), output pulse (red line) spectrum and interferometer TF (blue line). (For interpretation of the references to color in this figure legend, the reader is referred to the web version of this article.)

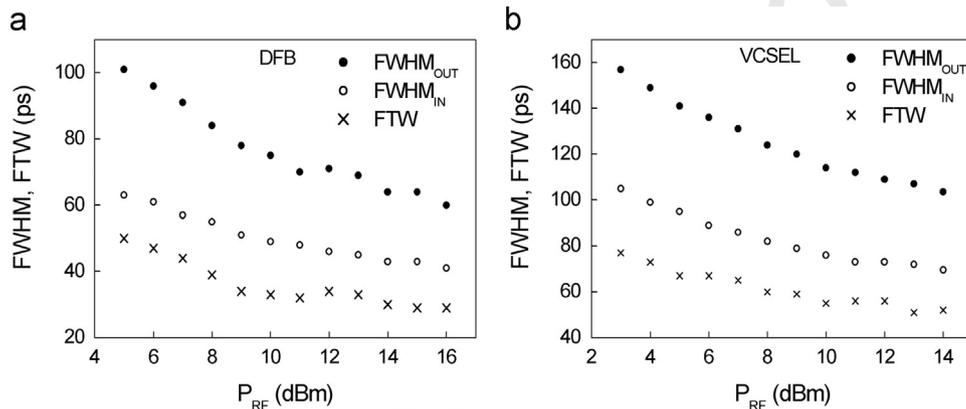


Fig. 10. Results obtained with DFB laser (a) and the VCSEL (b), as a function of P_{RF} , with $f_{RF}=1$ GHz and $I_{BIAS}=I_{TH}$ and $I_{BIAS}=1.1 I_{TH}$, for the DFB laser and the VCSEL, respectively. Input pulse FWHM ($FWHM_{IN}$, open circles), output pulse FWHM ($FWHM_{OUT}$, solid dots) and output pulse FTW (crosses).

spectral traces of the input and output pulses and the interferometer TF are shown in Fig. 9(b). Losses introduced by the spectral filtering process were experimentally determined by measuring the pulse peak amplitude after polarizer $P1$ (input pulse) and after $P2$ (output pulse) and by re moving the EDFA from the set-up. The peak power attenuation was about 67%, for both the DFB laser and the VCSEL.

In order to test the flexibility of the proposed technique with respect to the input pulse durations, different input pulses were considered by varying the gain switching parameters for the device under study. The RF power was varied from 5 dBm to 16 dBm for the DFB laser and from 3 dBm to 14 dBm for the VCSEL and the VCSEL, respectively. The interferometer TF was varied as described previously in order to obtain the best flat top pulse profiles at the interferometer output.

The results are shown in Fig. 10(a) and (b), for the DFB laser and the VCSEL, respectively. The pulse FWHM duration of a GS laser decreases with increasing P_{RF} , until the second relaxation oscillation is excited and long tail or double peaked pulses are generated. The P_{RF} range has been chosen such that single peak pulses have been obtained for both devices. The FWHM of the generated pulses decreased with increasing P_{RF} , from 63 ps to 41 ps and from 105 ps to 69 ps, for the DFB laser and the VCSEL, respectively. The pulses obtained from the VCSEL show longer duration with respect to the DFB pulses, due to different device characteristics and operating conditions.

In all cases, flat top pulses with flat region oscillations $< 5\%$ were obtained, by placing a minimum of transmission close to the spectrum center and by varying the ER. The pulses obtained at the interferometer output had FWHM durations which are about 150%

longer than the FWHM of the input pulses, for both devices and in all cases.

The FTW obtained at the interferometer output are about the 70% of the FWHM duration of the input pulses, ranging from 50 ps to 29 ps in the DFB and from 77 ps to 52 ps in the VCSEL. The FTFF obtained in all experiments was around 0.55 and 0.59 for the DFB laser and the VCSEL, respectively. We attribute a greater value of the FTFF in the VCSEL to the different gain switching conditions and to the long tail of the pulses obtained with the DFB laser.

4. Conclusions

In this work, we propose a pulse shaping technique for the generation of flat top pulses from GS semiconductor lasers, using a polarization based Mach Zehnder interferometer with variable TF. The output pulse temporal profile is investigated theoretically as a function of the free spectral range and extinction ratio of the proposed interferometer, which are properly tuned by varying the two interferometer arms delay and the output coupling ratio, respectively.

The applicability of the proposed technique to different devices and pulses is demonstrated experimentally with the generation of flat top pulses from a GS DFB laser and a GS VCSEL, both emitting in the 1550 nm region. The gain-switching parameters are varied for each device under study in order to test the flexibility of the proposed technique on a wide range of input pulse durations: from 40 ps (shortest FWHM from the GS DFB laser) to 100 ps (longest FWHM from the GS VCSEL).

1 Flat top pulses are obtained with FWHM about 150% of the
2 input pulse FWHM and with intensity oscillations in the flat top
3 region smaller than 5% of the pulse peak. Power losses, intrinsic to
4 the proposed amplitude spectral filtering technique have been
5 measured, giving an attenuation of 67% of the input pulse intensity
6 peak.

8 **Acknowledgements**

9
10 The authors gratefully acknowledge the support of Ministerio
11 de Economía y Competitividad of Spain under project TEC2012-
12 38864-C03-02.

14 **References**

- 15
16
17 [1] P.P. Vasil'ev, I.H. White, J. Gowar, Rep. Prog. Phys. 63 (2000) 1997.
18 [2] R. Slavik, L.K. Oxenlowe, M. Galili, H.C.H. Mulvad, Y. Park, J. Azana, P. Jeppesen,
19 IEEE Photonics Technol. Lett. 19 (2007) 1855.

- [3] C. Vicario, A. Trisorio, G. Arisholm, C.P. Haur, Opt. Lett. 37 (2012) 1619.
[4] R. Selm, G. Krauss, A. Leitenstorfer, A. Zumbusch, Opt. Express 20 (2012) 5955.
[5] A.M. Weiner, Opt. Commun. 284 (2011) 3669.
[6] C. Guo, M. Nix, S.S. Yam, S. He, J. Lightwave Technol. 28 (2010) 876.
[7] Z. Tian, D.V. Plant, Opt. Lett. 36 (2011) 4542.
[8] Y. Park, M.H. Ashgari, T.-J. Ahn, J. Azaña, Opt. Express 15 (2007) 9584.
[9] P. Petropoulos, M. Ibsen, A.D. Ellis, D.J. Richardson, J. Lightwave Technol.
19 (2001) 746.
[10] M.A. Preciado, M.A. Muriel, Opt. Lett. 34 (2009) 752.
[11] R. Slavik, Y. Park, J. Azaña, IEEE Photonics Technol. Lett. 20 (2008) 806.
[12] R. Slavik, Y. Park, J. Azaña, Opt. Express 15 (2007) 6717.
[13] Y. Park, M. Kulishov, R. Slavík, J. Azaña, Opt. Express 14 (2006) 12670.
[14] A.M. Weiner, Rev. Sci. Instrum. 71 (2000) 1929.
[15] A. Consoli, I. Esquivias, Opt. Express 20 (2012) 22481.
[16] J.C. Cartledge, R.C. Srinivasan, J. Lightwave Technol. 15 (1997) 852.
[17] R. Hui, M. O'Sullivan, Fiber Optic Measurement Techniques, Elsevier Academic
Press, Boston (2009) 2009129–258.

UNCORRECTED PROOF